

Electronic Patent Application Fee Transmittal

Application Number:	10772510			
Filing Date:	05-Feb-2004			
Title of Invention:	Method and apparatus for examining semiconductor wafers in a context of die/SAW design			
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Filer:	Maria Mladen Eliseeva			
Attorney Docket Number:	21295.74 (H5742US)			
Filed as Large Entity				
Utility Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				
Extension - 3 months with \$0 paid	1253	1	1050	1050

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Request for continued examination	1801	1	810	810
Total in USD (\$)				1860